Fig.1

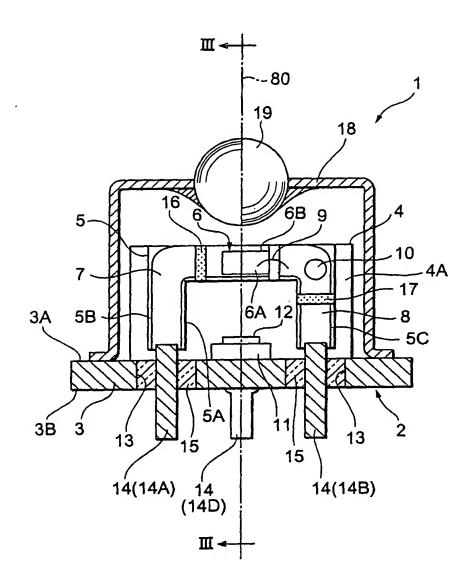


Fig.2

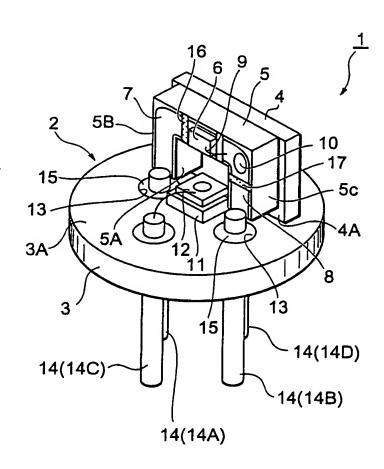


Fig.3

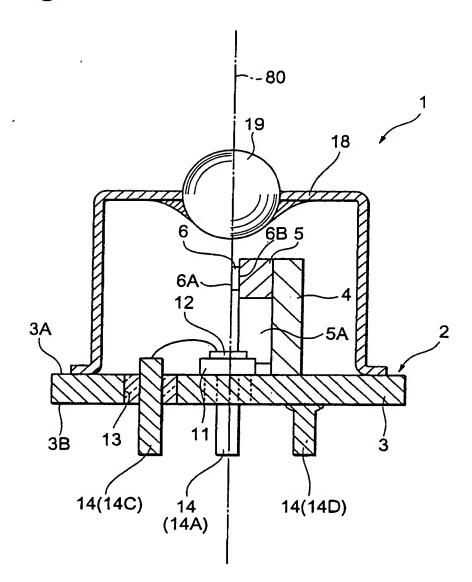
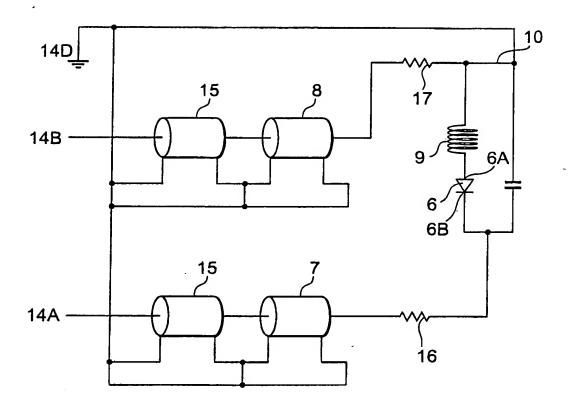


Fig.4



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Fig.5a

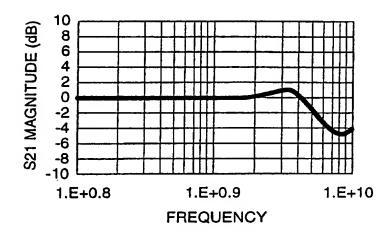


Fig.5b

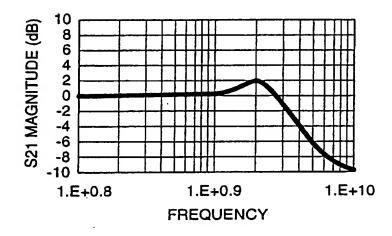


Fig.6

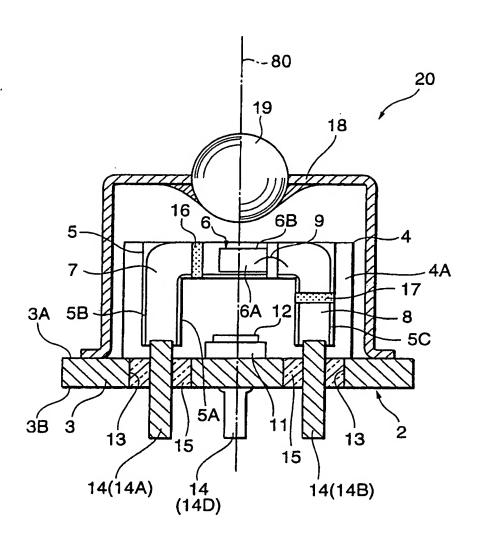
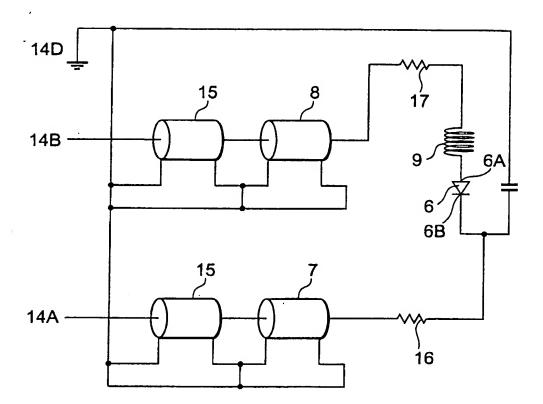
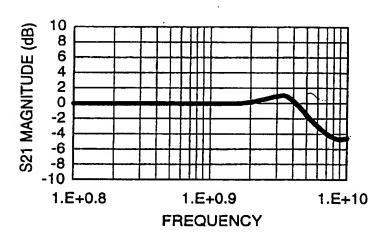


Fig.7



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Fig.8



2

Fig.9

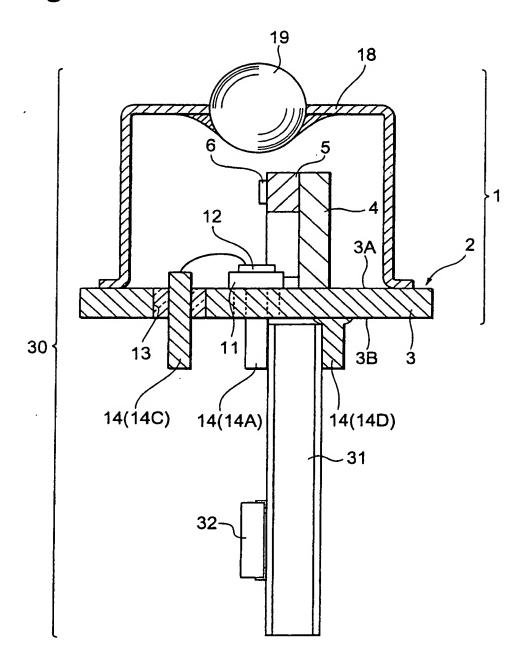


Fig.10

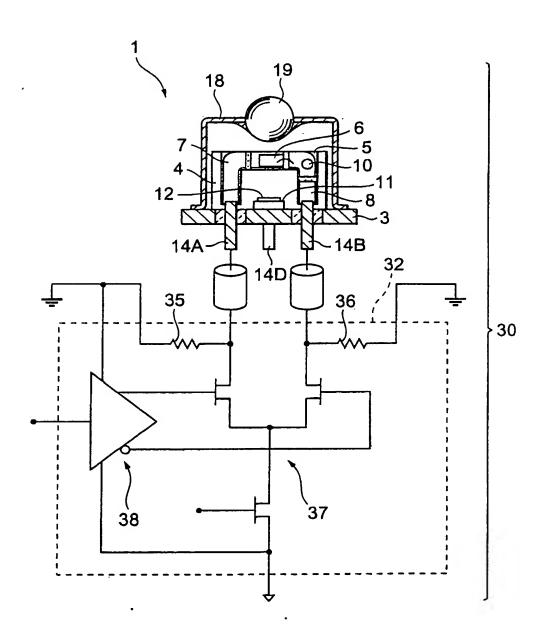


Fig.11

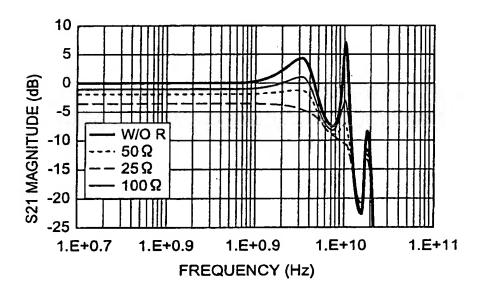


Fig.12a

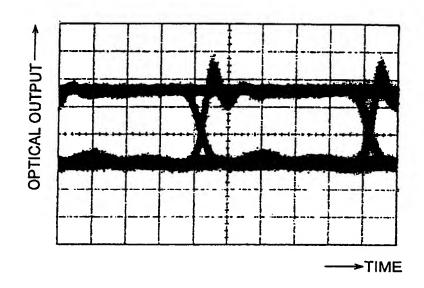


Fig.12b

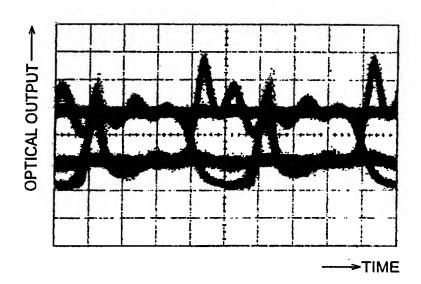
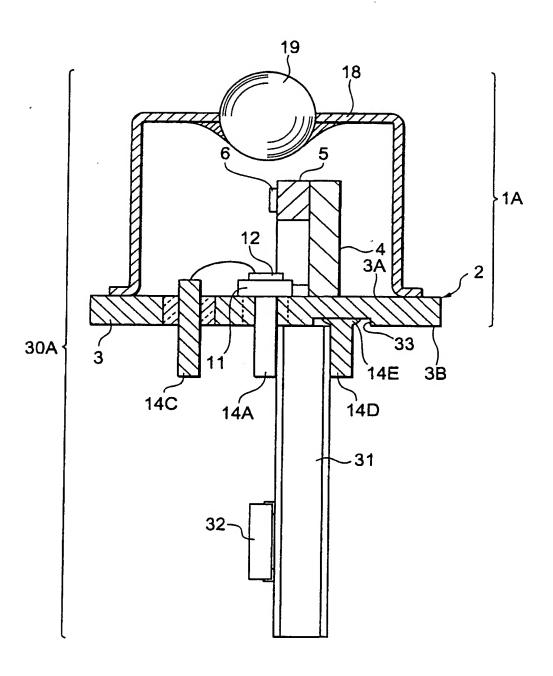


Fig.13



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Applicant(s): Tomoyuki Funada et al. SEMICONDUCTOR LASER MODULE AND SEMICONDUCTOR LASER APPARATUS

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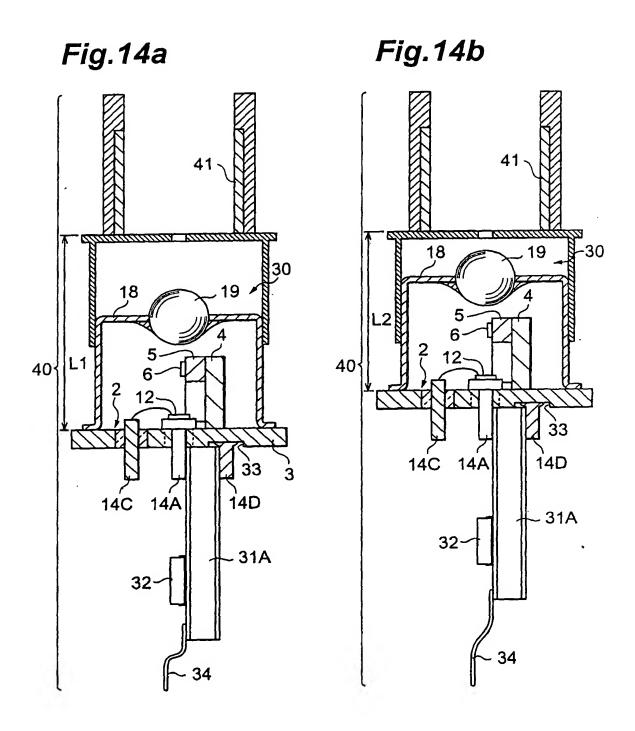
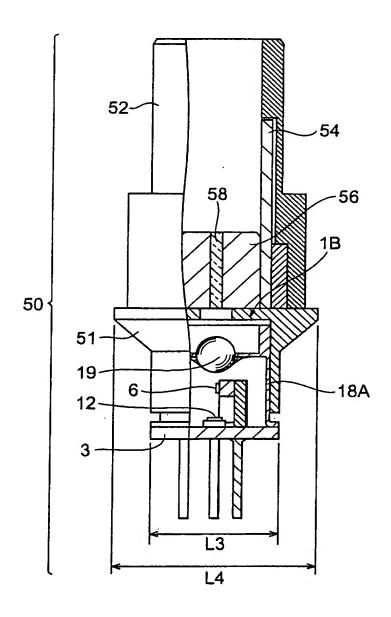


Fig.15



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Fig.16a



Fig.16b

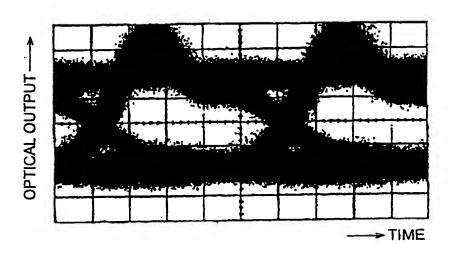


Fig.17

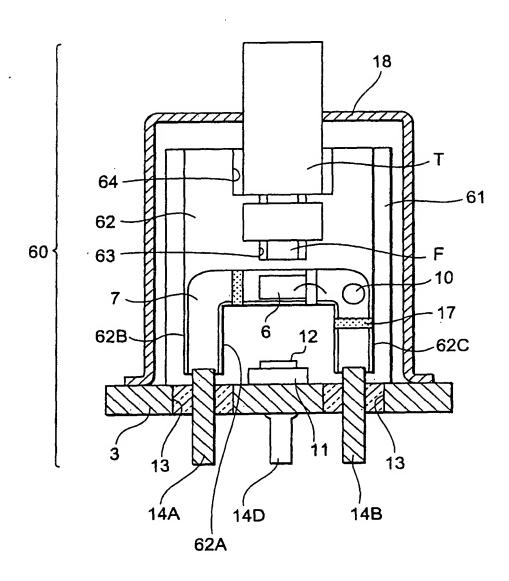


Fig.18

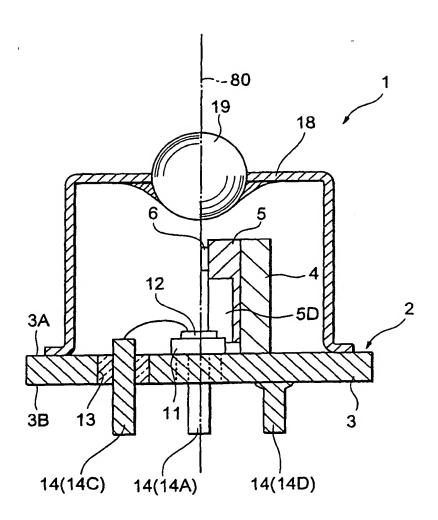


Fig.19

